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Bib Data Sheet

CONFIRMATION NO. 7739

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|---|---|---|------------------------|---------------------------------------|
| SERIAL NUMBER 10/003,908 | FILING DATE 11/01/2001 RULE | CLASS 438 | GROUP ART UNIT 2812 | ATTORNEY DOCKET NO. M-112021 US |
| APPLICANTS William R. Entley, San Jose, CA; John G. Langan, Pleasanton, CA; Randy Hall, San Cruz, CA; | | | | |
| CONTINUING DATA <i>None</i> | | | | |
| FOREIGN APPLICATIONS <i>None</i> | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED 01/24/2002 | | | | |
| Foreign Priority claimed 35 USC 119 (a-d) conditions met | <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance | STATE OR COUNTRY CA | SHEETS DRAWING 4 | TOTAL CLAIMS 21 |
| Verified and Acknowledged <i>[Signature]</i> | Examiner's Signature <i>[Signature]</i> Initials | INDEPENDENT CLAIMS 1 | | |
| ADDRESS David E. Steuber SKJERVEN MORRILL MacPHERSON LLP Suite 700 25 Metro Drive San Jose, CA 95110-1349 | | | | |
| TITLE In situ plasma process to remove fluorine residues from the interior surfaces of a CVD reactor | | | | |
| FILING FEE RECEIVED 758 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other <input type="checkbox"/> Credit | | |